



## Stereo Microscope

Continuously zoom

Using excellent optical system, has a clearer image, and can maintain high-quality and bright imaging at any magnification. It is the first choice for modern electronic industry inspection and equipment. Suitable for PCB/LCD/IC assembly inspection.

| Stereo Microscope   |   |  |   |
|---------------------|---|--|---|
| Model               | PMS-SM45S   | PMS-SM60S  | PMS-SM45D   |
| Observation Head    | 45° tilted binocular observation head, pupil distance adjustment: 54mm-75mm, fixed eyepiece tube;   | 45° tilted binocular observation head, pupil distance adjustment: 54mm-75mm, fixed eyepiece tube;  | 45° tilted binocular observation head, pupil distance adjustment: 52mm-76mm, fixed eyepiece tube; |
|                     | Oblique binocular observation head tilted at 45° interpupillary distance adjustment: 54mm-75mm, fixed eyepiece tube, with fixed and fixed locking function; | 45° tilted trinocular observation head, interpupillary distance adjustment: 54mm-75mm, fixed eyepiece tube, with fixed and fixed locking function; | 45° tilted binocular observation head, pupil distance adjustment: 52mm-76mm, fixed eyepiece tube; |
|                     | /   | 60° tilted trinocular observation head, interpupillary distance adjustment: 54mm-75mm, fixed eyepiece tube, with fixed and fixed locking function; | /   |
| Eyepiece            | High eye point large field eyepiece WF10TX20mm adjustable diopter, micrometer can be installed;   | High eye point large field eyepiece WF10TX22mm adjustable diopter, micrometer can be installed;  | High eye point large field eyepiece WF10TX22mm adjustable diopter, micrometer can be installed;   |
|                     | High eye point large field eyepiece WF15TX15mm adjustable diopter, micrometer can be installed;   | High eye point large field eyepiece WF15TX15mm adjustable diopter, micrometer can be installed;  | High eye point large field eyepiece WF15TX16mm adjustable diopter, micrometer can be installed;   |
|                     | High eye point large field eyepiece WF20TX10mm adjustable diopter, micrometer can be installed;   | High eye point large field eyepiece WF20TX10mm adjustable diopter, micrometer can be installed;  | High eye point large field eyepiece WF20TX12mm adjustable diopter micrometer can be installed;    |
| Objective Lens      | 0.70X~4.5X zoom lens working distance 100mm;  | 0.67X-4.5X zoom lens working distance 100mm;   | 0.67X-4.5X zoom lens working distance 100mm;  |
|                     | /   | 0.8X-5.0X zoom lens working distance 100mm;  | /   |
|                     | /   | 1.0X-6.7X s zoom lens working distance 100mm;  | /   |
| Auxiliary Objective | 0.3X/287mm, 0.4X/217mm, 0.5X/177mm, 0.7X/120mm, 1.5X/47mm, 2X/26mm;   |  |   |
| Frame               | Integrated stand arm type with frame;   |  |   |
|                     | Dismantable column type, can be equipped with any frame;  |  |   |
| Base                | Flat base;  |  |   |
|                     | Base with light source;   |  |   |
| Photographic Device | Camera receiver, adjustable focus;  |  |   |

